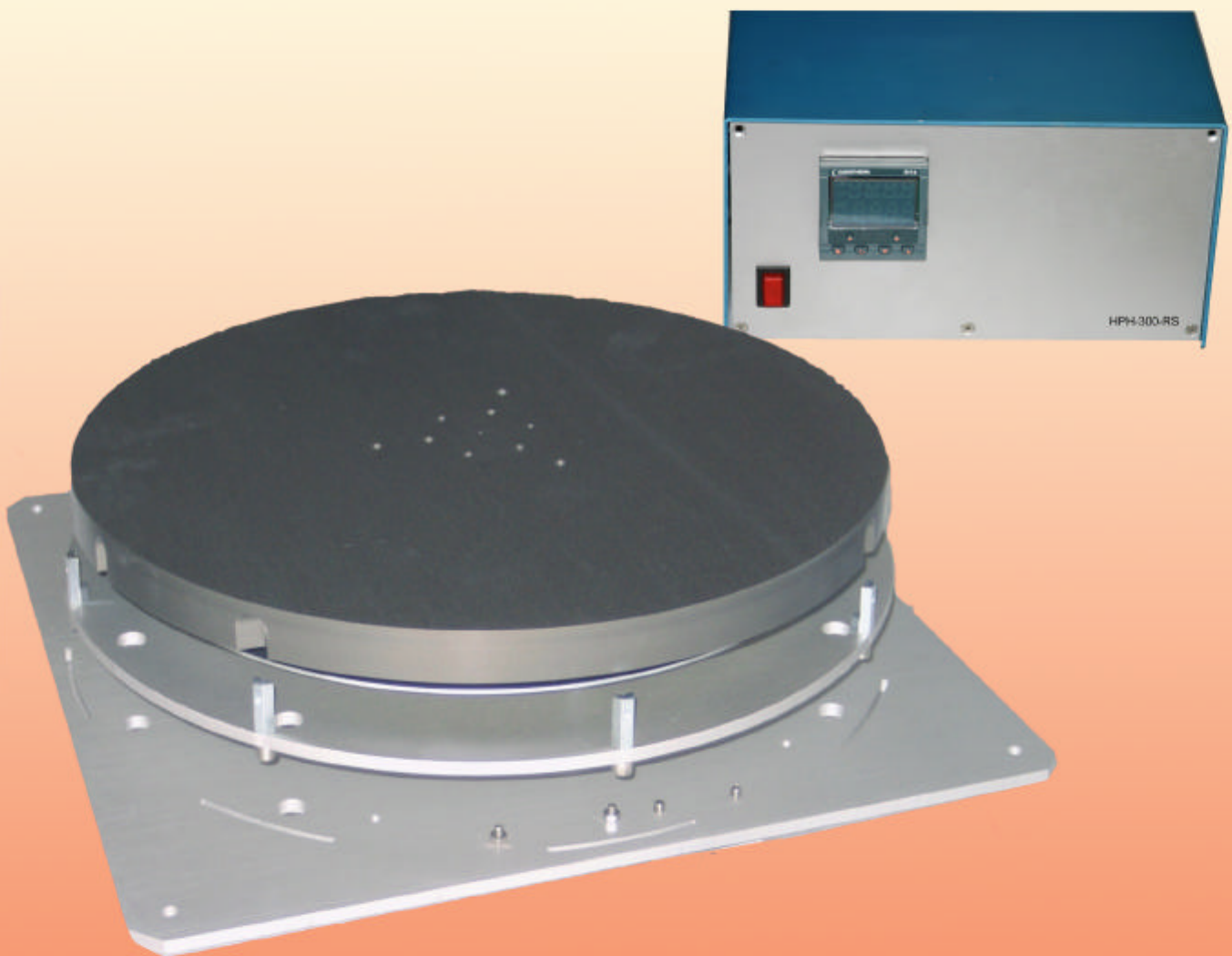


Hot chuck with lift pins
for up to 300mm wafer size
Model HPH-300



- * as built-in or stand-alone model available
- * with RS-232 interface PC connection

- Hot chuck with lift pins for wafers up to 12" (300mm)
- with external controller
- as build-in or stand-alone unit
- time controlled lift-pins (the lift pins are adjustable – depends on your wafer size)
- new: RS-232 interface for connection to a PC
- High precision Eurotherm controller model 2416
- vacuum hold



HPH-300
stand-alone version



Controller back side

Technical Data	HPH-300
Heated area:	306mm
Temperature range:	room temperature up to 250°C
Vacuum hold:	in the middle of the chuck
Power supply:	230 V/1600Watt or 115V/1600 Watt
Dimension chuck	330x330x130mm, 6 kgs
Dimension controller:	220x220x125mm, 3 kgs